



**ELECTRONIC COPY**

LG747594885  
Report verification at igi.org



November 10, 2025  
IGI Report Number **LG747594885**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUSHION MODIFIED BRILLIANT**  
Measurements **14.43 X 10.54 X 7.01 MM**  
**GRADING RESULTS**  
Carat Weight **8.42 CARATS**  
Color Grade **E**  
Clarity Grade **VVS 2**

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**GRADING RESULTS**

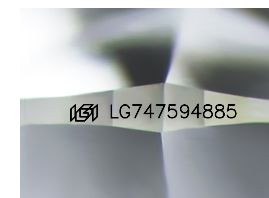
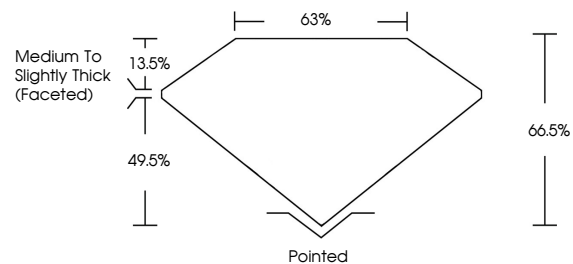
Carat Weight **8.42 CARATS**  
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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **LG747594885**

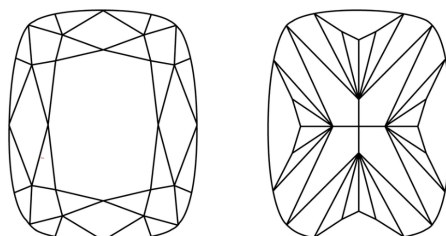
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

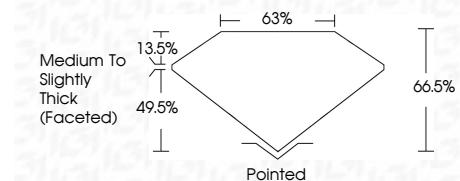
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**CUSHION MODIFIED BRILLIANT**  
**14.43 X 10.54 X 7.01 MM**  
**8.42 CARATS**  
**E**  
**VVS 2**  
**66.5%**  
**63%**  
**Medium to Slightly Thick (Faceted)**  
**Pointed**  
**EXCELLENT**  
**EXCELLENT**  
**NONE**  
**IGI LG747594885**  
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